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** CONTINUING DATA *****

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** FOREIGN APPLICATIONS *****

JAPAN 2004-025923 02/02/2004

** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **

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35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No					
Verified and /G. NAGESH NAGESH RAO/ Acknowledged Examiner's Signature		Initials	JAPAN	3	52	9

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TITLE

Silicon single crystal, a silicon wafer, an apparatus for producing the same, and a method for producing the same

FILING FEE RECEIVED 3700	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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